

PATENT ATTY. DOCKET NO. SAMD/18US3

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

: Strauss et al.

Art Unit: 1109

Serial No.

: 08/881,948

Examiner: R. McDorRECEIVED

Filed

: June 25, 1997

For

: MECHANICALLY JOINED SPUTTERING TARGET AND ADAPTOR 1998

THEREFOR

Assistant Commissioner of Patents Washington, DC 20231

**GROUP 1100** 

## RESPONSE TO OFFICE ACTION

In response to the Office Action mailed December 19, 1997, please amend the application as follows:

## In the Claims:

(Amended) A target for installation in a vacuum chamber for processing a substrate by causing spattering material to be ejected from the target onto said substrate, comprising a generally disk-shaped section having two generally planar surfaces and [a cylindrical] an outer periphery,

[manufactured homogeneously of said sputtering material,] \_said generally disk-shaped section having at least one radially-inward step proximate said outer periphery

said target being manufactured homogeneously of said sputtering material.

> I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postage prepaid in an envelope addressed to: Assistant Commissioner of Patents, Washington, D.C. 20231 on: March 19, 1998.

Thomas W. Humphrey Reg. No. 34,353